



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application	)	<u>PATENT APPLICATION</u>
	)	
Inventor(s):	)	
Roessig, et al.	)	Art Unit: 2819
	)	
Application No.:	)	
10/738,375	)	Examiner: Chang, Daniel D.
	)	
Filed:	)	
December 17, 2003	)	
	)	
Title:	)	<u>Customer No. 28554</u>
ACTUATION CIRCUIT FOR	)	
MEMS STRUCTURES	)	

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8**

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 25, 2006.

Larry E. Vierra, Reg. No. 33,809  
Signature Date: January 25, 2006

**RESPONSE A TO OFFICE ACTION UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This RESPONSE A is in reply to the Office Action mailed July 26, 2005.

**AMENDMENTS to the CLAIMS** begin on Page 2 of this paper.

**REMARKS** begin on Page 7 of this paper.